

# Usage Policy

- $\text{Cu}_2\text{O}$  target will be used as in Orion Sputter as well as NMPF Lab's AJA sputter tool.
- The thin film deposition is to be done at room temperature. Deposition at higher temperature to be avoided to avoid thermal degradation
- Protective gears like hand gloves, face mask and safety goggles to be used while handling the target.
- When not in use it should be stored in desiccators to avoid moisture contact.